

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Sun et al.

Examiner: Thanh V. Pham

Serial No.: 10/621,292

Group Art Unit: 2823

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For: **METHOD OF FABRICATING SEMICONDUCTOR DEVICE USING A
NICKEL SALICIDE PROCESS**

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Commissioner for Patents
P.O. Box 1450
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RESPONSE

Sir:

This paper is being filed in response to the Final Office Action dated April 3, 2007.
